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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: FRABOULET, David, et al.
SERIAL NO.: unassigned
FILING DATE: herewith
TITLE: Method for Making a Wire Nanostructure in a Semiconductor Film
EXAMINER: UNASSIGNED
ART UNIT: UNASSIGNED

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Prior to examination, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims, which begins on page 3 of this paper.

Remarks / Arguments begin on page 5 of this paper.